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APPLICANTS

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** CONTINUING DATA *****

None

** FOREIGN APPLICATIONS *****

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Verified and Acknowledged	<i>[Signature]</i> Examiner's Signature <i>[Initials]</i>				

ADDRESS

22852
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TITLE

Semiconductor wafer dividing method and apparatus

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____
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